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PPLICATION N	О.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/944,488		08/30/2001	Warren M. Farnworth	3996US (99-0254)	1571
24247	7590	04/22/2004		EXAM	INER
TRASK BRITT				LUK, EMMANUEL S	
P.O. BOX 2550 SALT LAKE CITY, UT 84110		7 TEC 04110	·	ART UNIT	PAPER NUMBER
		r, U1 84110		1722	TALER HOMEEN
				DATE MAILED: 04/22/2004	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)
· e	09/944,488	FARNWORTH, WARREN M.
Office Action Summary	Examiner	Art Unit
	Emmanuel S. Luk	1722
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with	the correspondence address
A SHORTENED STATUTORY PERIOD FOR REPL THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a repl - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailin earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply within the statutory minimum of thirty (3 will apply and will expire SIX (6) MONTH e, cause the application to become ABAN	ly be timely filed  30) days will be considered timely.  IS from the mailing date of this communication.  NDONED (35 U.S.C. § 133).
Status		
1) Responsive to communication(s) filed on 19 J	anuary 2004.	
2a) This action is <b>FINAL</b> . 2b) ☐ This	s action is non-final.	
3) Since this application is in condition for allowated closed in accordance with the practice under the second condition of the condition for allowated conditions are second conditions.		
Disposition of Claims		
<ul> <li>4)  Claim(s) 1-31 and 51-66 is/are pending in the 4a) Of the above claim(s) is/are withdra 5)  Claim(s) 17-31 and 51-66 is/are allowed.</li> <li>6)  Claim(s) 1-16 is/are rejected.</li> <li>7)  Claim(s) is/are objected to.</li> <li>8)  Claim(s) are subject to restriction and/or</li> </ul>	wn from consideration.	
Application Papers		
9) The specification is objected to by the Examine	er.	
10) The drawing(s) filed on is/are: a) acc	cepted or b) objected to by	the Examiner.
Applicant may not request that any objection to the		
Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the E		
Priority under 35 U.S.C. § 119	è	
<ul> <li>12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:</li> <li>1. Certified copies of the priority documen</li> <li>2. Certified copies of the priority documen</li> <li>3. Copies of the certified copies of the priority application from the International Burea</li> <li>* See the attached detailed Office action for a list</li> </ul>	ts have been received. ts have been received in Appority documents have been re nu (PCT Rule 17.2(a)).	olication No eceived in this National Stage
Attachment(s)  1) Notice of References Cited (PTO-892)	4) 🗌 Interview Sui	mmary (PTO-413)
Notice of References Cited (PTO-892)     Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/	Mail Date
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08 Paper No(s)/Mail Date <u>12</u> .	5) Notice of Info 6) Other:	ormal Patent Application (PTO-152)

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#### **DETAILED ACTION**

#### Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (a) the invention was known or used by others in this country, or patented or described in a printed publication in this or a foreign country, before the invention thereof by the applicant for a patent.
- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims 1, 2, 4 and 5 are rejected under 35 U.S.C. 102(b) as being anticipated by Rano, Jr. et al (5286426).

Rano teaches the claimed apparatus having a first platen (20) with a plurality of alignment elements projecting therefrom (24), the sets of alignment elements for engaging sets of alignment features of a like electronic component assembly and a second platen (22) having a plurality of spaced locations corresponding to the first platen (20), including sets of alignment receptacles (68). The alignment elements are pins (38).

## Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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- 4. The factual inquiries set forth in *Graham* v. *John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:
  - 1. Determining the scope and contents of the prior art.
  - 2. Ascertaining the differences between the prior art and the claims at issue.
  - 3. Resolving the level of ordinary skill in the pertinent art.
  - 4. Considering objective evidence present in the application indicating obviousness or nonobviousness.
- 5. Claims 3 and 6-16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Rano, Jr. et al (5286426) as applied to claim 1, and further in view of Steijer et al (5985185).

Rano teaches the claimed apparatus having a first platen (20) with a plurality of alignment elements projecting therefrom (24), the sets of alignment elements for engaging sets of alignment features of a like electronic component assembly and a second platen (22) having a plurality of spaced locations corresponding to the first platen (20), including sets of alignment receptacles (68). The alignment are pins and there at least two alignment elements located adjacent each component cavity (Fig. 1).

Rano fails to teach at least two alignment elements located adjacent each component cavity, a clamping element and further subdivision of subcavities.

Steijer et al teaches the claimed apparatus having a first platen (1) with a plurality of alignment elements projecting therefrom (73, 85), the sets of alignment elements for engaging sets of alignment features of a like electronic component assembly and a second platen (17) having a plurality of spaced locations corresponding to the first platen (19), including sets of alignment receptacles (87). The alignment are pins and

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there at least two alignment elements located adjacent each component cavity (Fig. 1). The first and second plates are releasably securable via clamping structure (Col. 9, lines 27-34 and 38-45). It would have been obvious to one of ordinary skill in the art to modify Rano with the alignment elements and clamping element as taught by Steijer because it allows for better alignment and thus improved molding by the apparatus.

In regards to the multiple subcavities, Rano teaches producing encapsulation of semiconductor members in a mold cavity between a first and second plate and it would have been obvious to one skilled in the art for modifying the apparatus with multiple cavities for a multiplied effect. *In re Harza*, 124 USPQ378 (CCPA 1960).

# Allowable Subject Matter

- 6. Claims 17-31 and 51-66 are allowed.
- The following is an examiner's statement of reasons for allowance: The prior art of record fails to teach a stereolithography machine having a first and second platen having sets of alignment elements and a plurality of cavities that engage the platen assembly support structure, the system further having a computer for and machine vision system for controlling the stereolithography system. In claim 51, the system enables inversion of the platen assembly via rotation about a horizontal axis. The closest prior art, Rano et al, Farnsworth et al, Steijer et al and Chang et al, fail to teach this arrangement of the platen structure located in a stereolithography apparatus.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Response to Arguments

8. Applicant's arguments, see amendment, filed January 19, 2004, with respect to the rejection(s)of claim(s) 1-16 under Steijer have been fully considered and are persuasive. Therefore, the rejection has been withdrawn. However, upon further consideration, a new ground(s) of rejection is made in view of Rano, Jr et al.

The applicant's arguments concerning the prior art reference of Steijer have been considered and in particular the component cavities extending 'therethrough' the second platen has been noted. The new prior art, Rano, does have this feature along with the first platen accommodating with a plurality of electronic component assemblies.

#### **Conclusion**

9. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Emmanuel S. Luk whose telephone number is (571) 272-1134. The examiner can normally be reached on Monday-Thursday 7 to 4 and alternate Fridays.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wanda L. Walker can be reached on (571) 272-1151. The fax phone

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number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

EL

W. L. WALKER SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 1700